

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Eiji KIMURA, EIJI

Confirmation No. 2801

U.S. Patent Application No. 10/812,014

Group Art Unit: 2877

Filed: March 30, 2004

Examiner: Tu Nguyen

For:

OPTICAL CHARACTERISTICS MEASURING APPARATUS, METHOD AND

**RECORDING MEDIUM** 

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of *October 5, 2004*, please amend the above-identified application as follows: